

# **Wafer Silicon-Based Solar Cells**

Lectures 10 and 11 – Oct. 13 & 18, 2011

MIT Fundamentals of Photovoltaics 2.626/2.627

Prof. Tonio Buonassisi

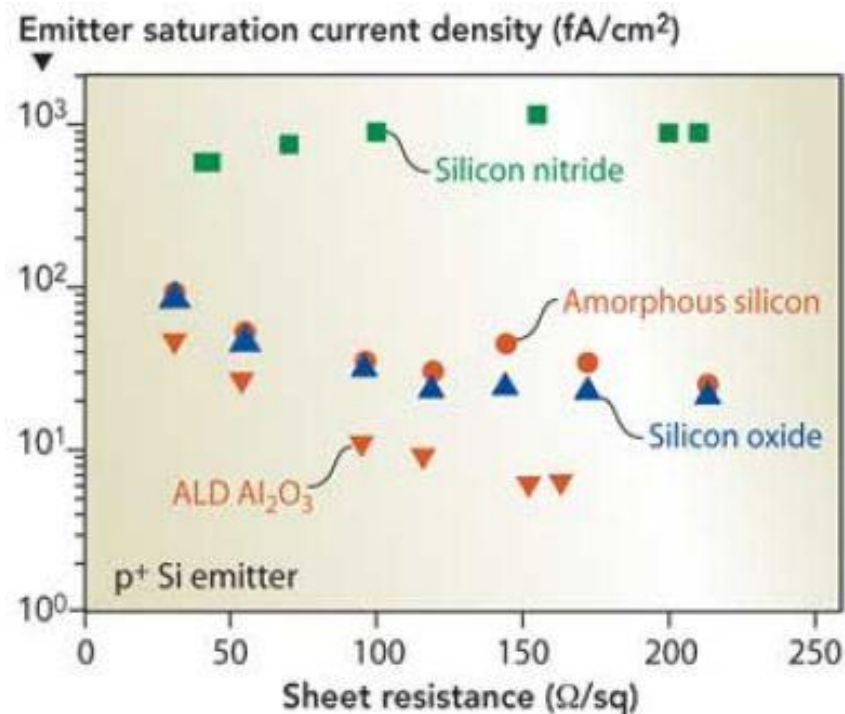
# Silicon-Based Solar Cells Tutorial

- Why Silicon?
- Current Manufacturing Methods
- Next-Gen Silicon Technologies



# Rationale for Si-based PV

- Passivating Oxide Layer
  - Low surface recombination velocity.
  - Effective diffusion barrier



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[http://www.pennenergy.com/index/power/display/7519461660/articles/Photovoltaics-World/volume-2009/Issue\\_4/features/minimizing-losses.html](http://www.pennenergy.com/index/power/display/7519461660/articles/Photovoltaics-World/volume-2009/Issue_4/features/minimizing-losses.html)

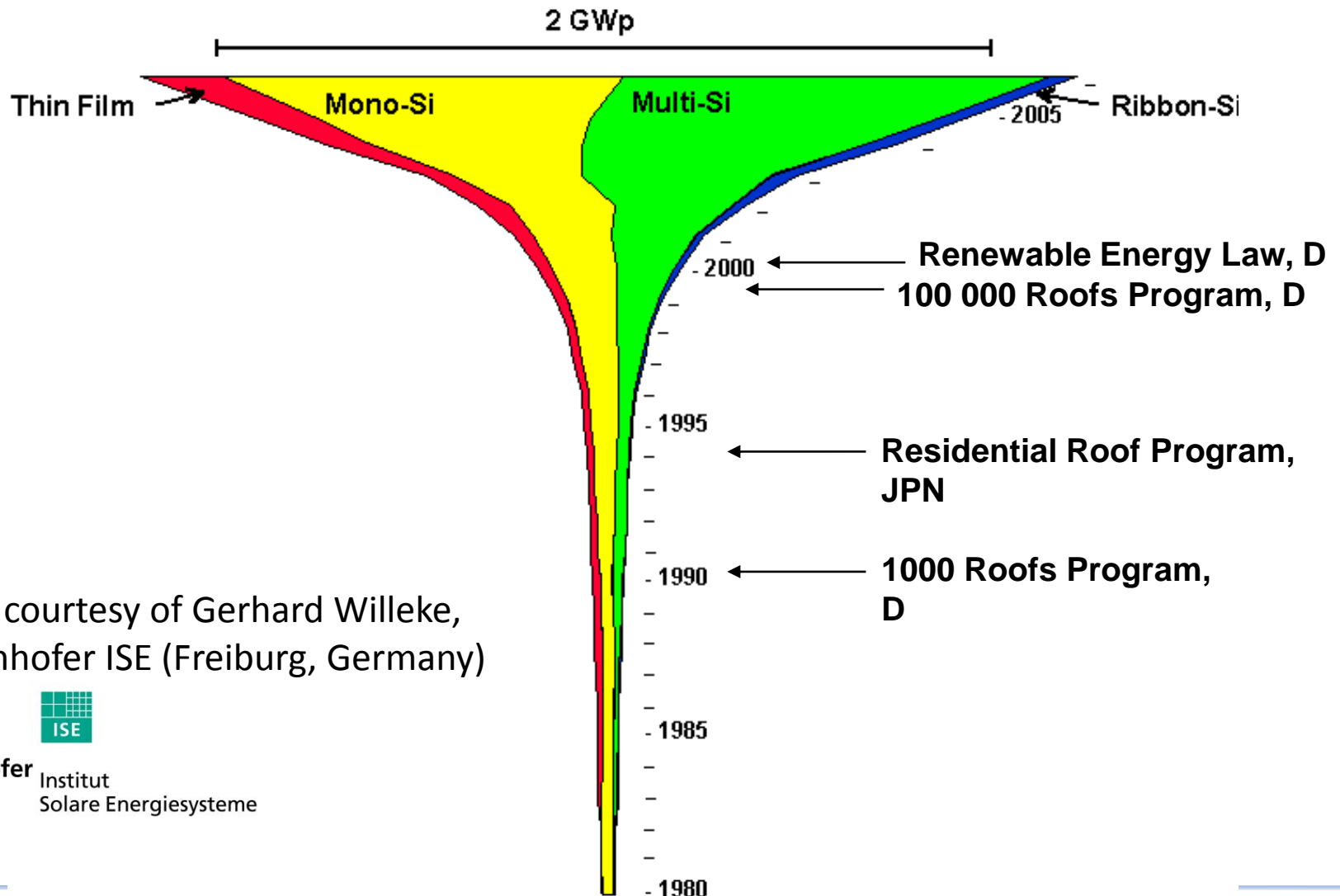
# Rationale for Si-based PV

- Momentum:
  - Most common semiconductor material
  - 50+ years of manufacturing and R&D experience
  - \$50B industry today
  - Technology acceptance results in low interest rates

# Silicon-Based Solar Cells Tutorial

- Why Silicon?
- Current Manufacturing Methods
  - Overview: Market Shares
  - Feedstock Refining
  - Wafer Fabrication
  - Cell Manufacturing
  - Module Manufacturing
- Next-Gen Silicon Technologies

# Photovoltaics: State of the Art



Slide courtesy of Gerhard Willeke,  
Fraunhofer ISE (Freiburg, Germany)



Fraunhofer  
Institut  
Solare Energiesysteme

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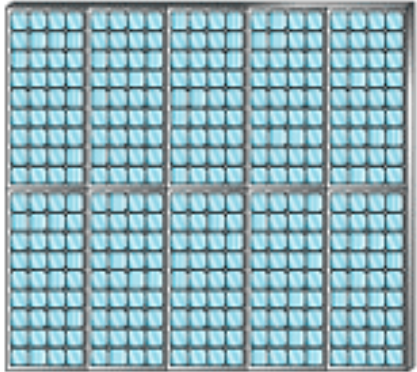
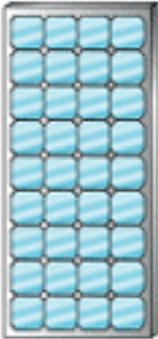
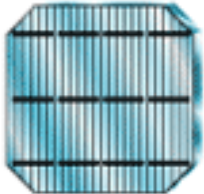
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# Si-based PV Production: From Sand to Systems

## Feedstock Refining



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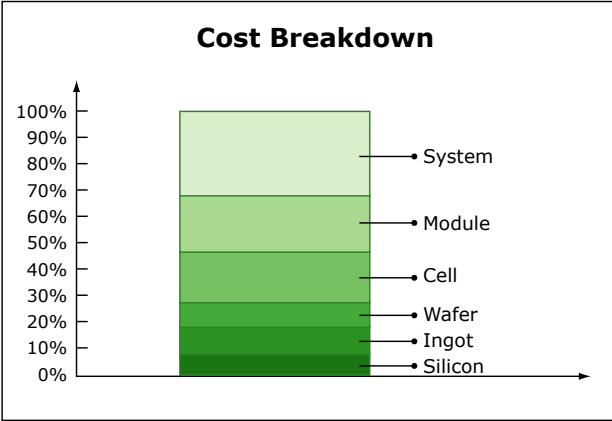


Image by MIT OpenCourseWare. After H. Aulich, PV Crystalox Solar.

# Step 1: Metallurgical-Grade Silicon (MG-Si) Production

For MG-Si production visuals, please see the lecture 10 video.

# MG-Si Market

- Approx. 1.5–2M metric tons of MG-Si produced annually.<sup>1</sup>
- ~6% of MG-Si produced annually is destined for PV. The remainder goes to the IC industry (~4%), silicones (~25%), metal alloys including steel and aluminum (~65%).

<sup>1</sup>Source: [http://www.photon-magazine.com/news\\_archiv/details.aspx?cat=News\\_PI&sub=worldwide&pub=4&parent=1555](http://www.photon-magazine.com/news_archiv/details.aspx?cat=News_PI&sub=worldwide&pub=4&parent=1555)

# MG-Si Outlook

- PV is the fastest-growing segment of the MG-Si market (approx. 40%/yr).
- Approx. 2 kg of MG-Si are used to make 1 kg of refined silicon.
- Additional refining capacity needed to keep up with PV growth.

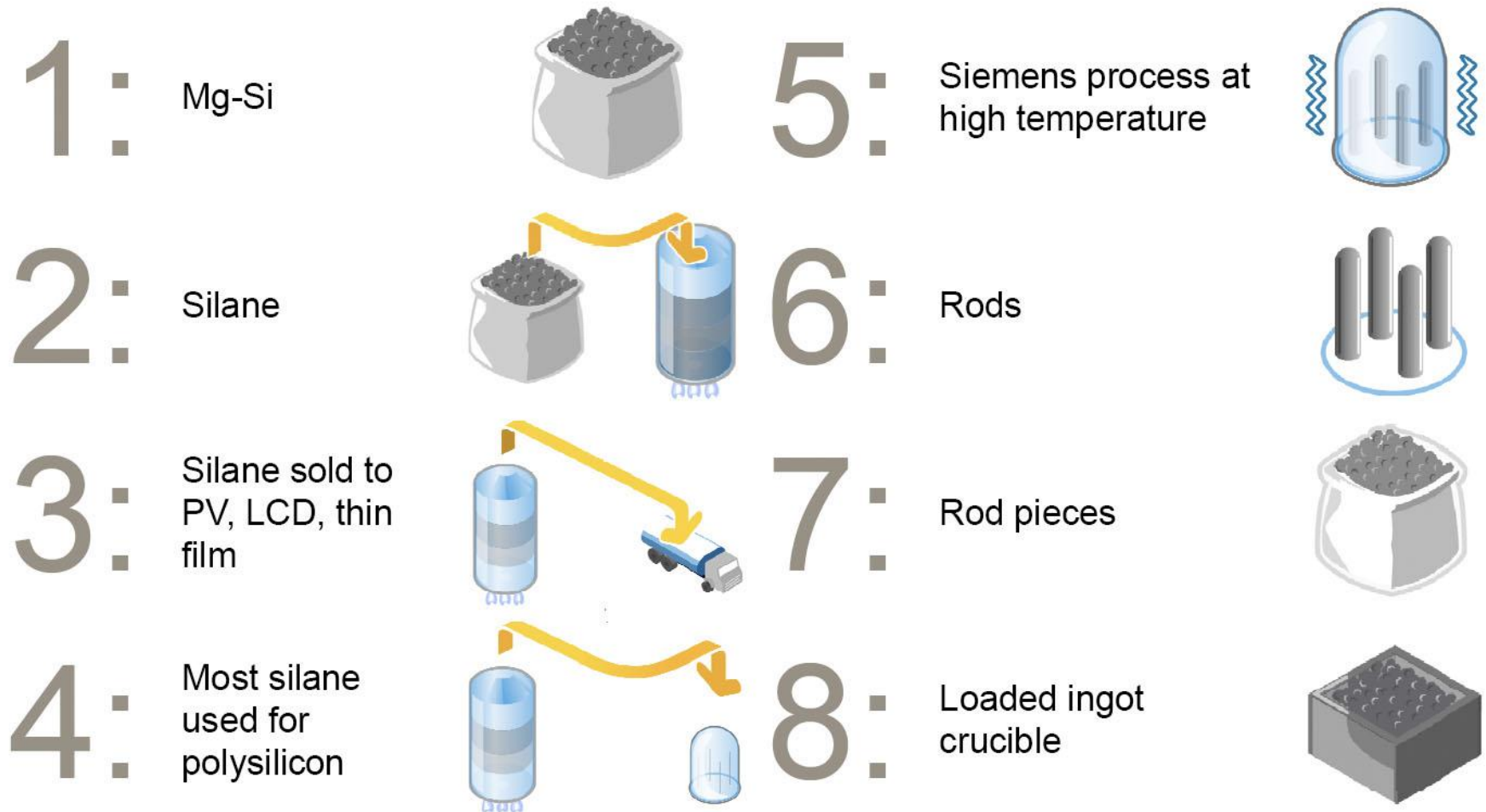
# Standard Silicon Feedstock Refining Process: The “Siemens Process”

*(purification through gaseous distillation)*

# Step 2: Semiconductor-Grade Silicon Production

Field trip  
March  
27-29, 2007

## Current polysilicon production process



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# Silane Production

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Image Source: REC

# PolySi Production

- Traditionally very high purity (9N, or ~99.9999999%), appropriate for the semiconductor industry.
- Recently, process adjusted for lower cost, resulting in 6N Solar-Grade Silicon (SoG-Si)

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See the lecture 10 video for this content.

Image Source: REC



# Scale: Large Plants, Long Lead Times

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**Source: REC**

- Lead time for new factory: typically 18-24 months
- Investment: 100's of M\$.

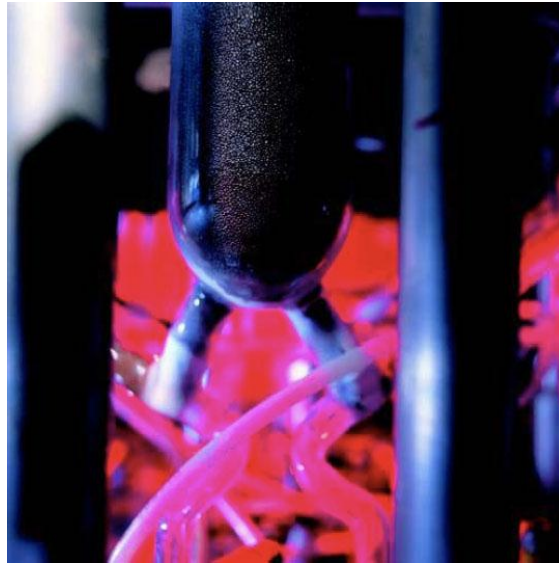
# PolySi Outlook

- Scale: Poly-Si production ~120,000 MT/year (over half for PV industry).
- Cost ~ 25 \$/kg
  - *2010 Price ~ 50-70 \$/kg (long-term contracts)*
  - *2008 Price ~ 500 \$/kg (spot market)*
- Slow response to changing demand: Long leadtimes and large cost of capacity expansion result in oscillatory periods of over-supply and under-supply.

# Alternative Solar-Grade Silicon Feedstock Refining Processes

- Fluidized Bed Reactor (FBR)
- Upgraded Metallurgical-Grade Silicon (UMG-Si): Purification through liquid route.

# FBR: Fluidized Bed Reactor



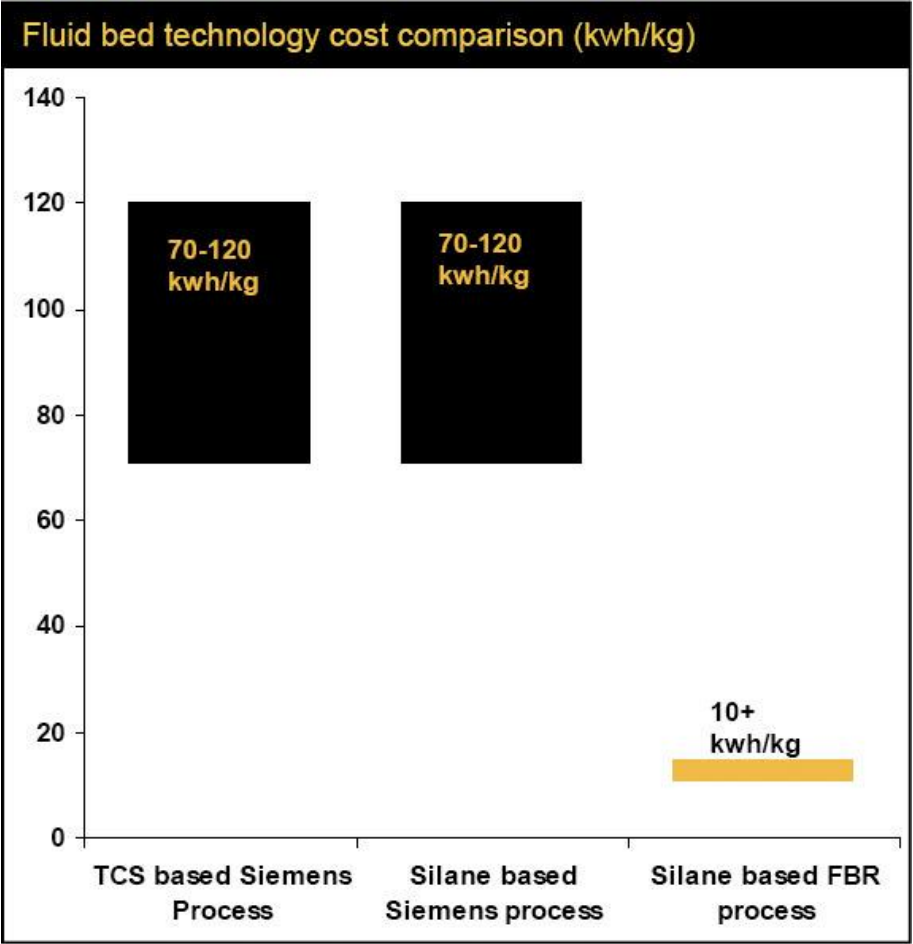
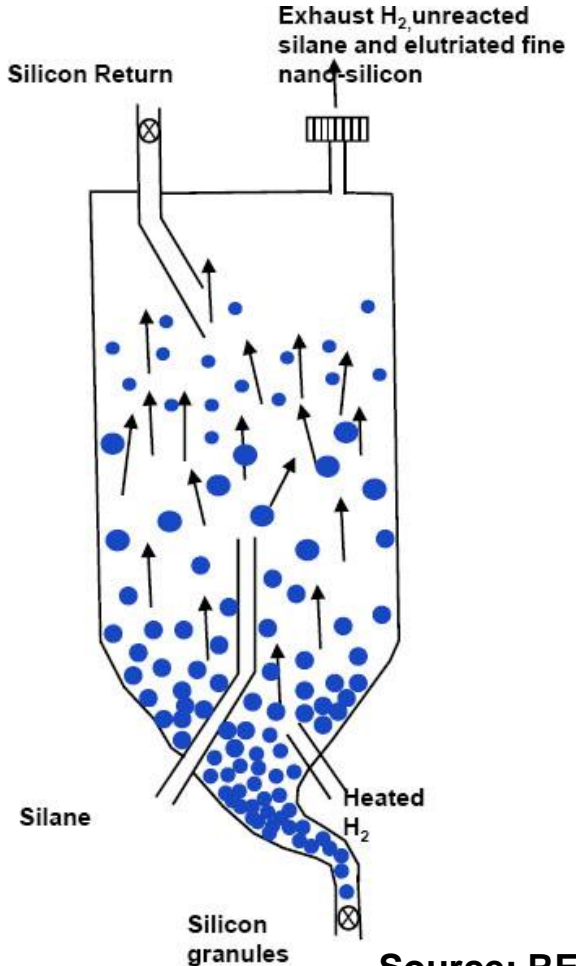
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**Source: REC**

**Advantage: Smaller seeds, larger surface area/volume ratio, faster deposition!**

# FBR: Fluidized Bed Reactor



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# Upgraded Metallurgical-Grade Silicon (UMG-Si)

- Distinguished by liquid-phase purification

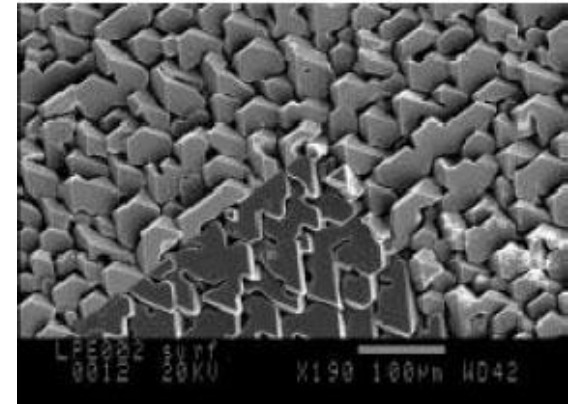
Slag Refining



Leaching



Solidification



Source: REC

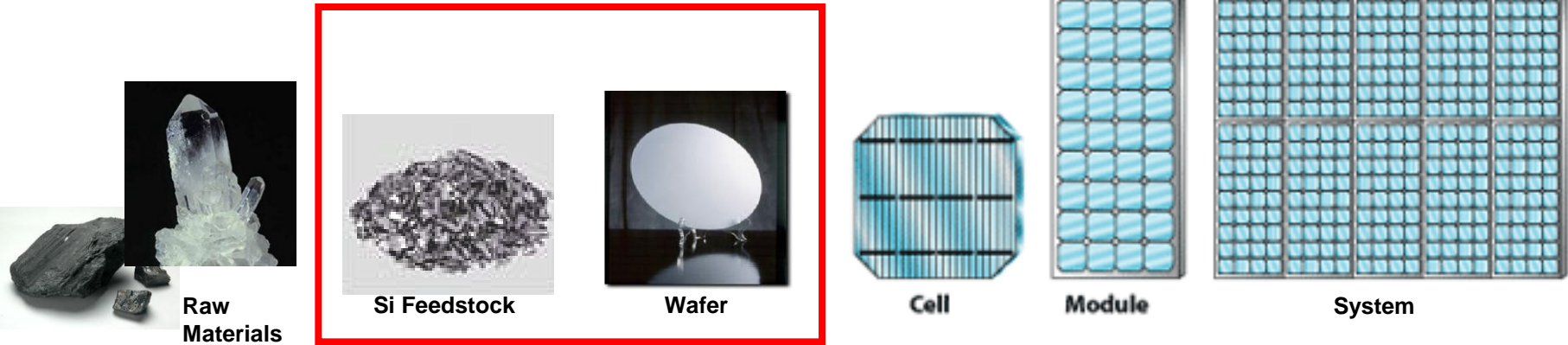
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# Si-based PV Production: From Sand to Systems

## Crystal Growth / Wafer Fab



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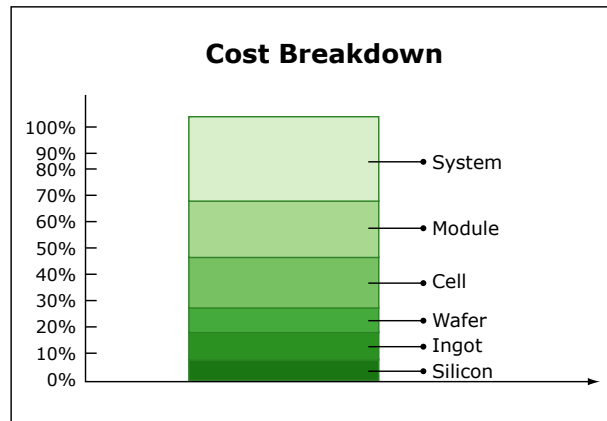


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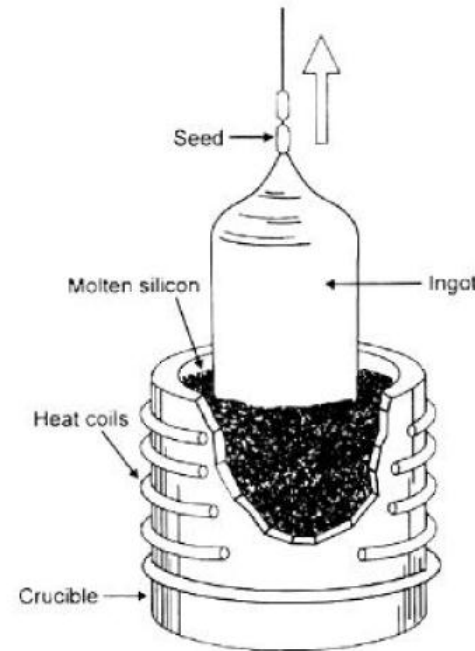
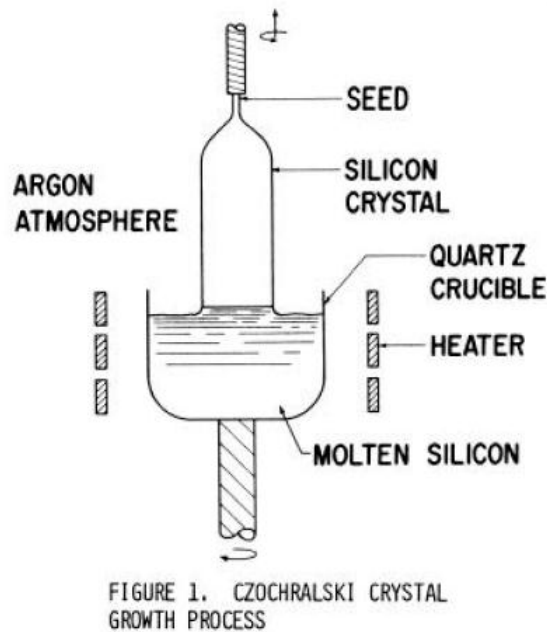


# Crystalline Silicon Wafer Technologies Used in PV

- Single-crystalline ingot growth (~35% of market)
  - *Mainly Czochralski, and some Float Zone.*
- Casting of multicrystalline silicon ingots (~50% of market)
- Ribbon growth of multicrystalline silicon (~1% of market)
- Sheet growth of multicrystalline silicon (~0% of market)

# Czochralski Growth

1916, Polish physicist Jan Czochralski



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Si melting point 1414°C

Growth rate approx. 5 cm/hour

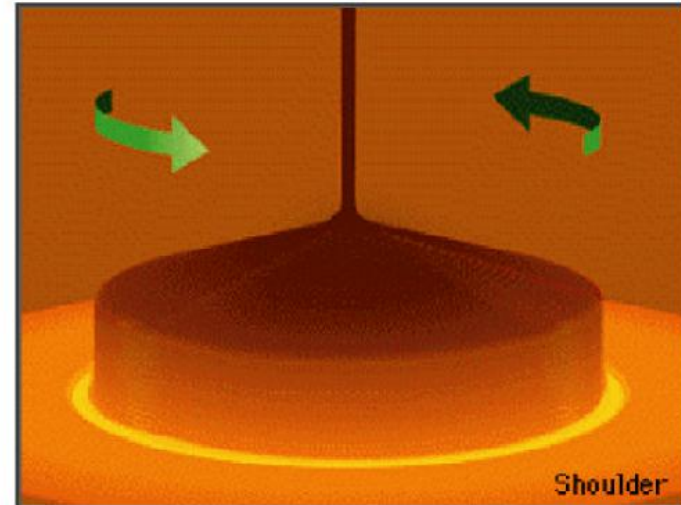
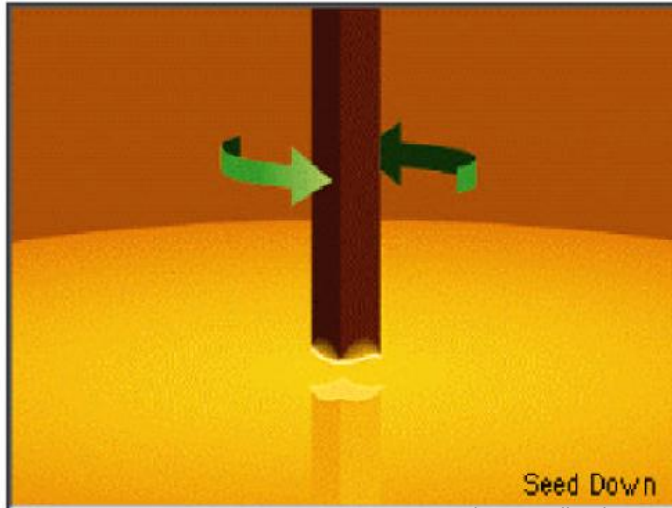
Typical crystal size:  
10-30 cm in diameter,  
1-2 meters long

This type of silicon is the standard for integrated circuit industry. Very high quality ingots. Partial dissolution of quartz crucible introduces oxygen and carbon into the melt.

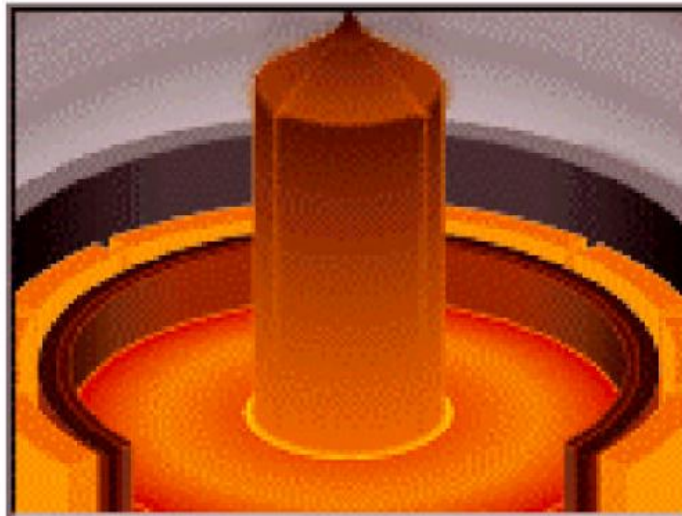
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# Principles of the CZ Growth Process



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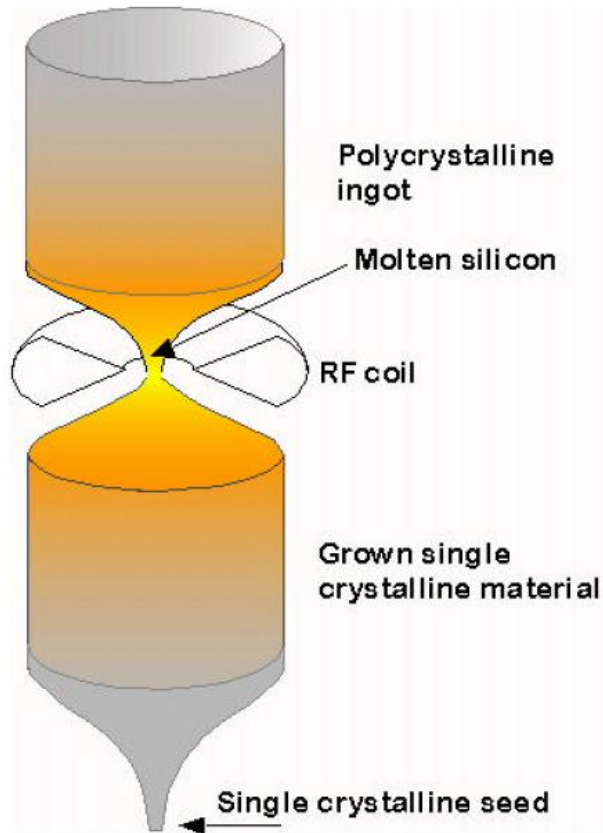


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# Float-Zone Growth



*Diameters and rotation speeds of the polysilicon ingot and the growing single crystals can be different*

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Crystal grows without contact with crucible and has the lowest possible impurity content (particularly low oxygen and carbon content). However, FZ growth appears to be more expensive than CZ growth and is used only for the most demanding applications.

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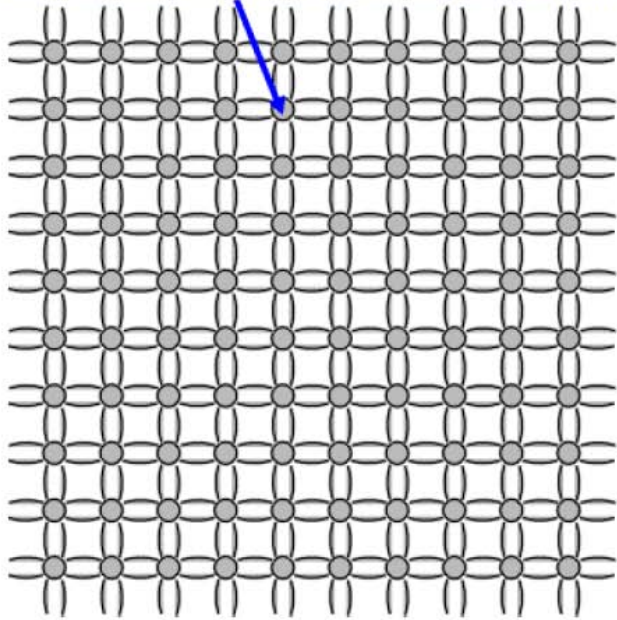
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# Crystalline Silicon

*Single crystalline silicon*

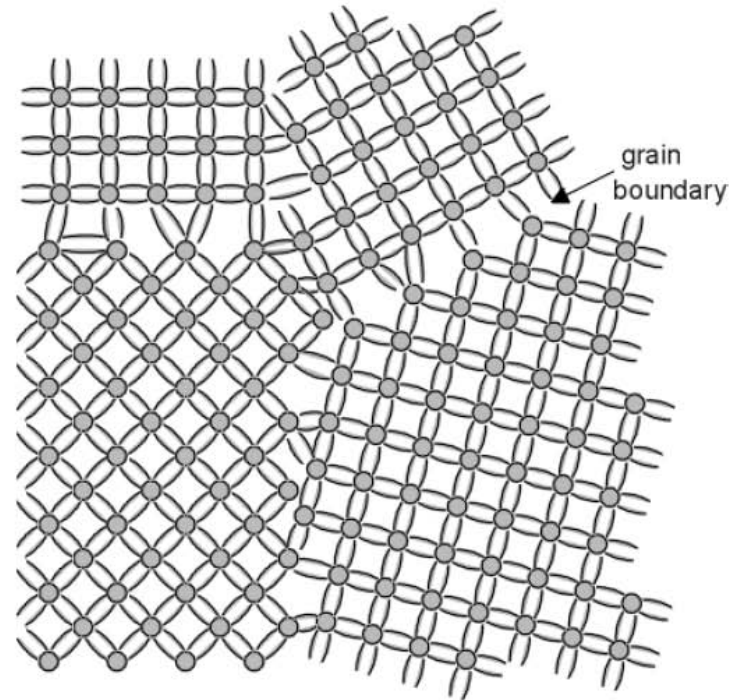
FZ, CZ

Each silicon atom is bonded to four neighbouring atoms.



*Multicrystalline silicon*

Cast, ribbon, sheet techniques



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The grain size in multicrystalline silicon is from several microns to several millimeters or even centimeters. The fundamental physical properties such as bandgap and absorption properties are similar. The difference between c-Si and mc-Si is primarily the density of defects and impurities – and **cost, cost, cost**.

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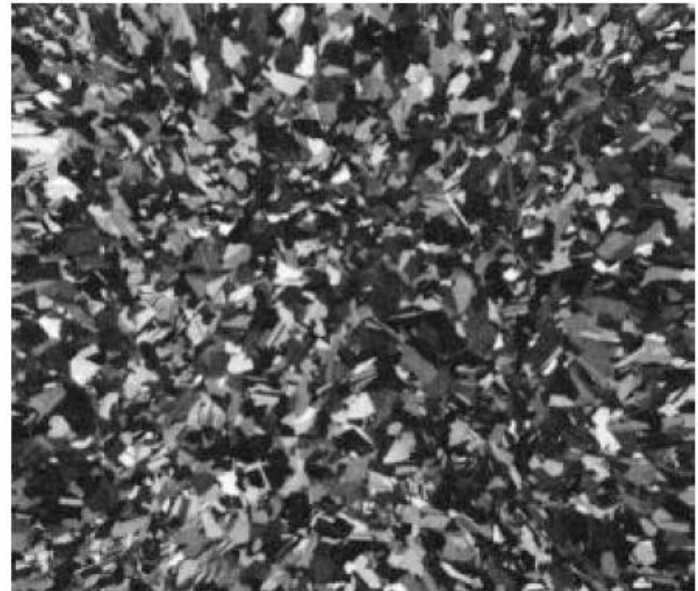
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# Distinguishing mc-Si from sc-Si

*grains in mc-Si are clearly visible in reflected light*



*Single-crystalline  
CZ or FZ wafer*



*Multicrystalline silicon wafer*

# Production of ingot mc-Si

1:

Solar grade silicon is first put into crucibles...



5:

The resulting massive ingot is cut into 16 blocks...



2:

...and melted in special furnaces



6:



3:

It is then cooled from the bottom, crystallization begins...



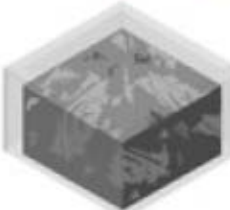
7:

...each again sliced into leaf-thin wafers



4:

...and multicrystalline silicon is formed



8:

Producing the thinnest wafers in Europe



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# Directional Solidification of mc-Si

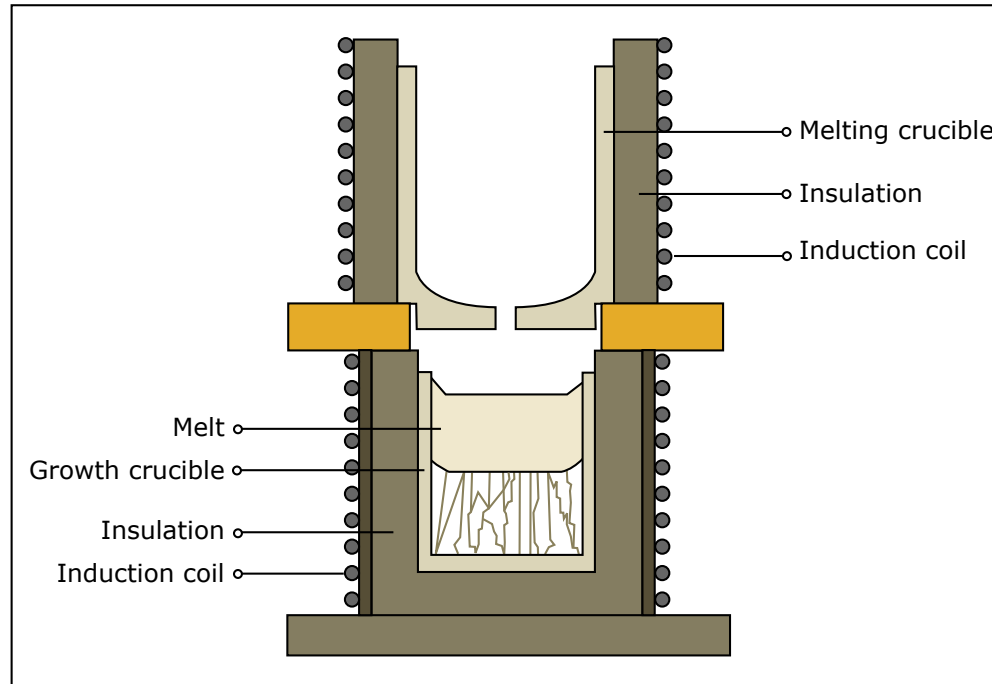


Image by MIT OpenCourseWare.

Silicon typically grown in a fused quartz crucible with  $\text{Si}_3\text{N}_4$  coating (to prevent adhesion). Total growth times of 20-30 hours.

Ingots as large as 600 kg are entering commercial production today, with 1 tonne ingots in R&D.



# Directional Solidification of mc-Si

*a.k.a. Directional Solidification System (DSS), Casting, Bridgman Process.*

Ingots are initially cut into rectangular blocks called “bricks,” then wire-sawed into wafers.

Please see lecture video for related furnace and brick-cutting images.

# Quiz #2 Announcement

- Pre-analysis (now on Stellar): 20% of Quiz 2 grade
- $\$/W_p$  metric: 10% of Quiz 2 grade
- Solar cell efficiency analysis: 70% of Quiz 2 grade

# Ribbon Growth

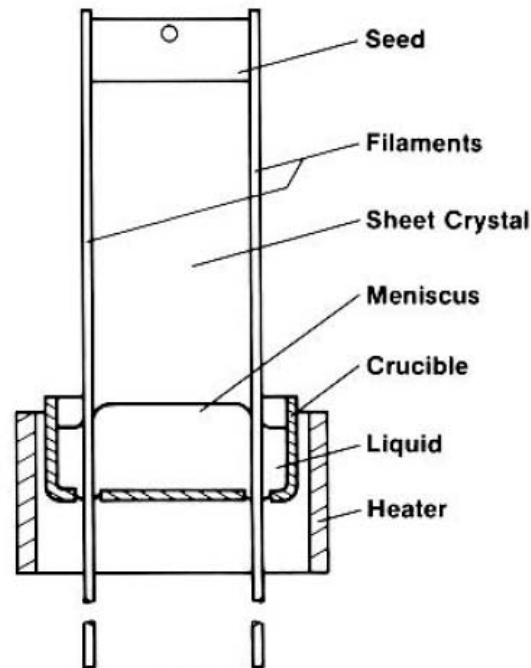
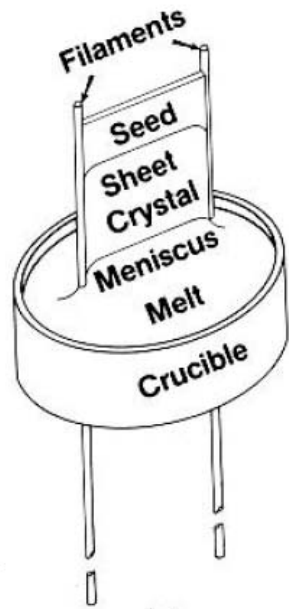
- Advantages: No kerf loss due to wire sawing, more efficient silicon utilization.
- Disadvantages: Traditionally, lower material quality → lower efficiencies. Traditionally, higher capex.

# Ribbon growth of mc-Si

String Ribbon Growth Technique (Evergreen Solar, Sovello)

E. Sachs, *J. Cryst. Growth* **82** (1987) 117

Similar technique: T.F. Cizek and J.L. Hurd, 1980: Edge-supported pulling



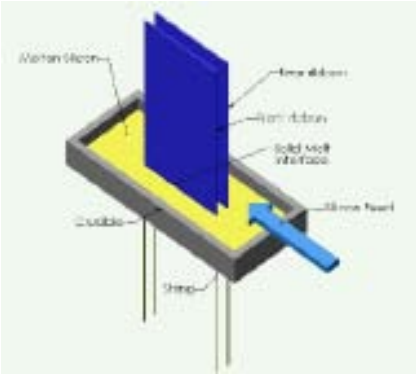
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*A good source of information on the basics:  
T.F. Cizek, J. Cryst. Growth 66, 655 (1984).*

Growth rate: 2-3 cm/min

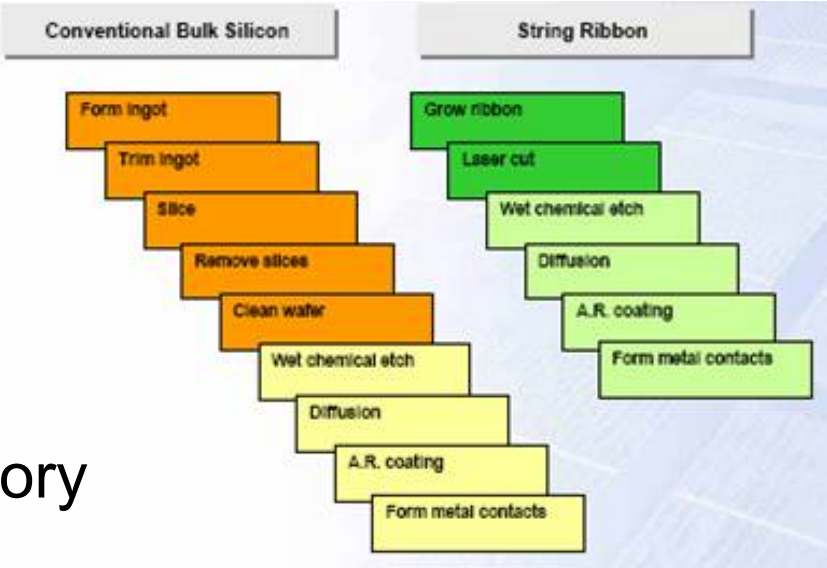
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# Ribbon growth of mc-Si



## 180 MW Sovello Factory

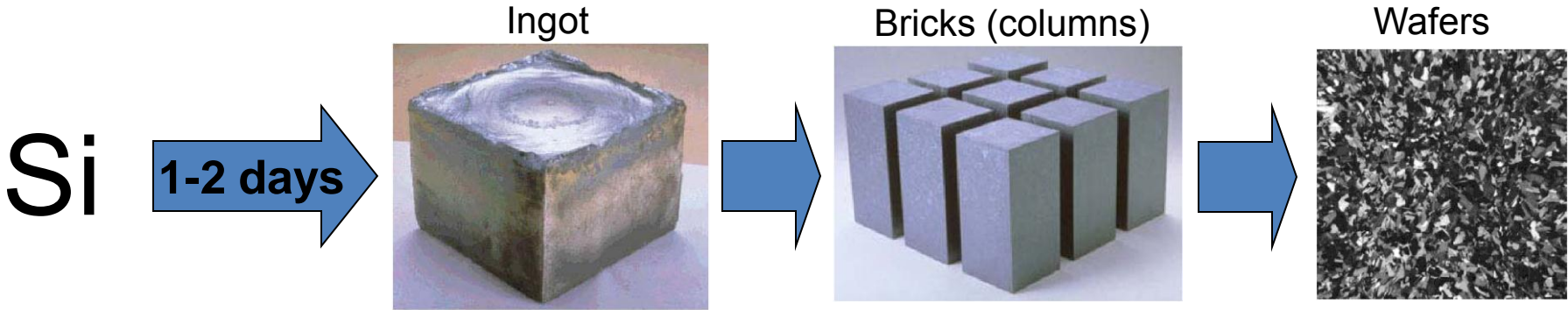
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8 x 180 cm wafer; <200 microns

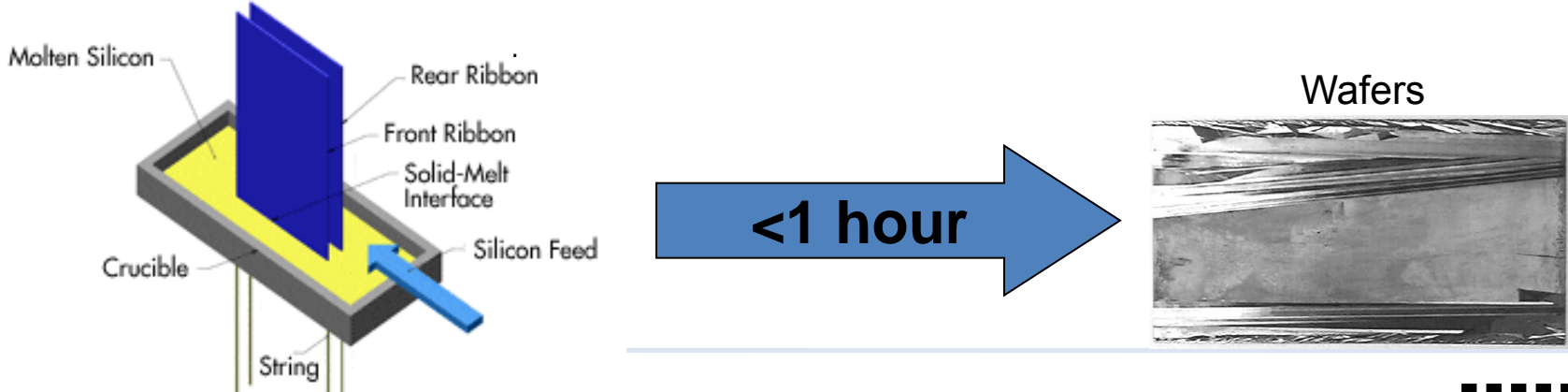
# Ribbon growth of mc-Si

**Ingot mc-Si: ~50% Si utilization**



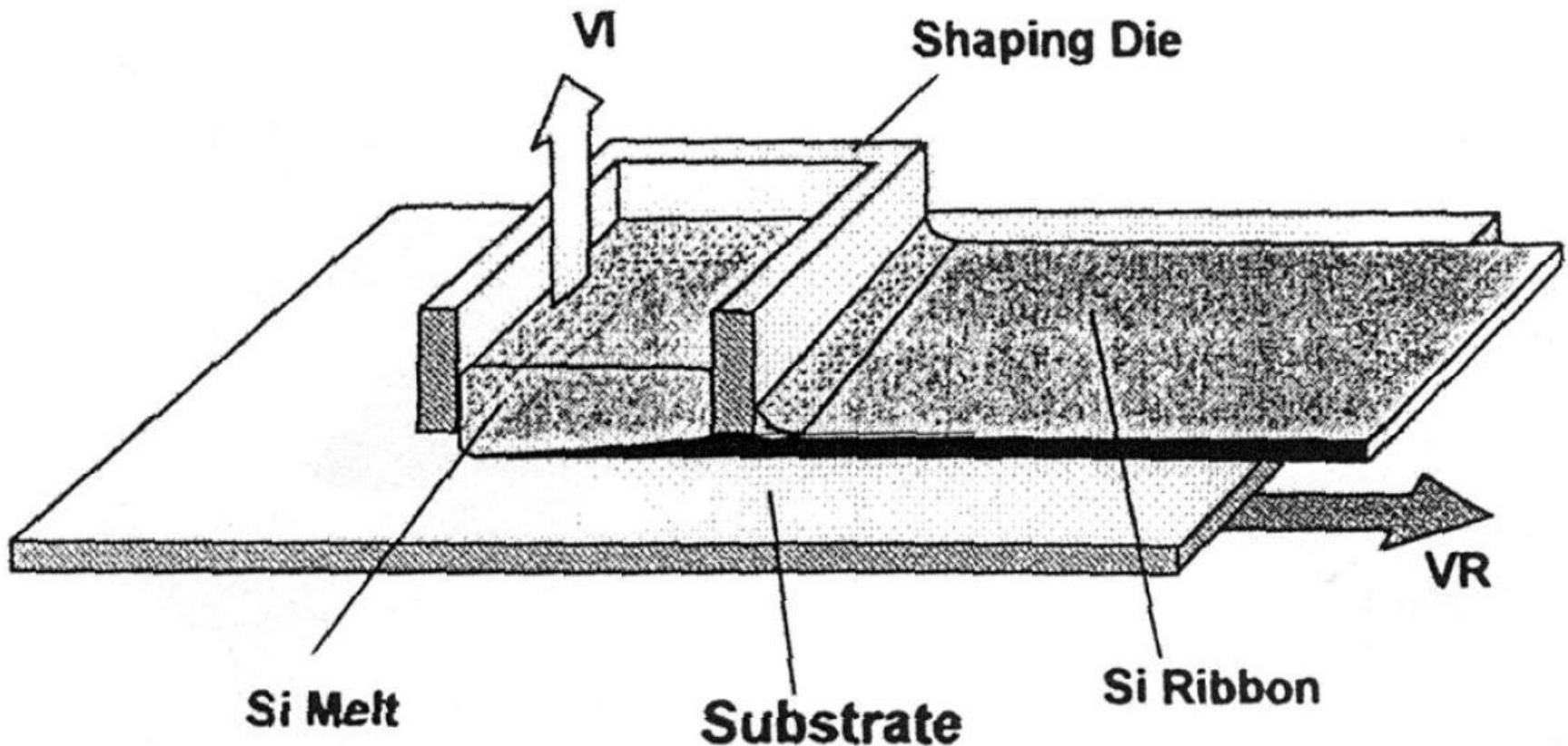
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## Ribbon or Sheet Growth: ~100% Si utilization



<http://www.evergreensolar.com/>

# Sheet Growth (Horizontal Ribbon)



Courtesy of Elsevier, Inc., <http://www.sciencedirect.com>. Used with permission.

- Schematic of Ribbon Growth on Silicon (RGS) growth process.
- 4-9 m/s pull speeds theoretically possible (VI & VR decoupled).

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# Wafer Fabrication: Next Directions

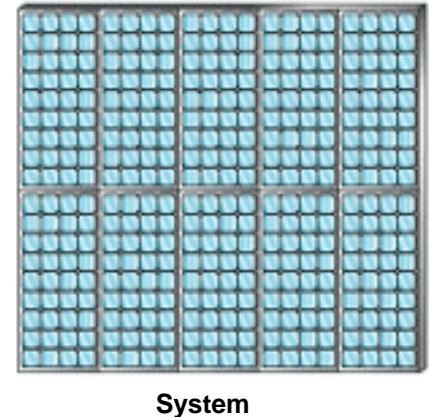
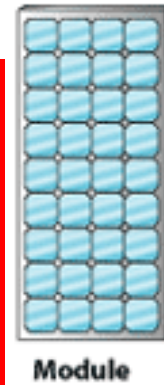
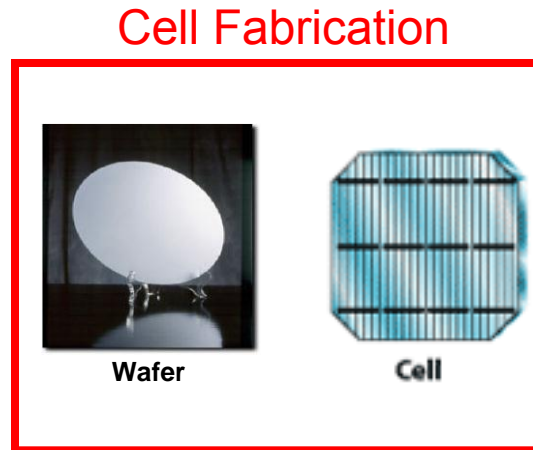
- Cost: Cost per watt can be reduced by:
  - *Using cheaper starting materials.*
  - *Growing/sawing thinner wafers.*
  - *Increasing furnace throughput (ingot size, growth speed).*
  - *Improving material quality.*
- Scaling Issues:
  - *Poly-Si production ~0.04M MT/year, half for semiconductor industry.*
  - *Slurry and SiC grit needed for ingot wire sawing.*
  - *50% Si loss due to wire sawing, ingot casting!*
- Technology Enablers:
  - *Use lower-quality feedstocks*
  - *Produce & handle thinner wafers*
  - *Grow faster, larger, higher-quality ingots.*



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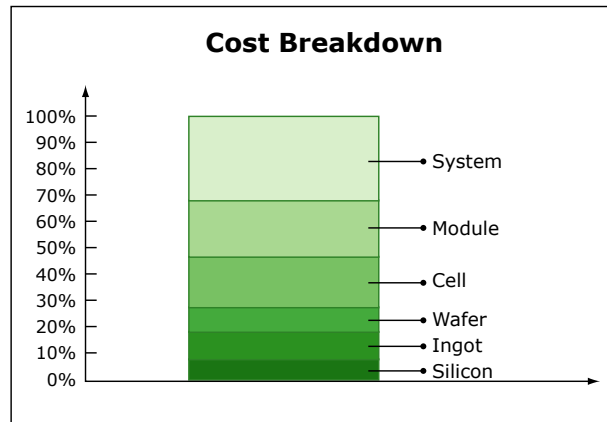
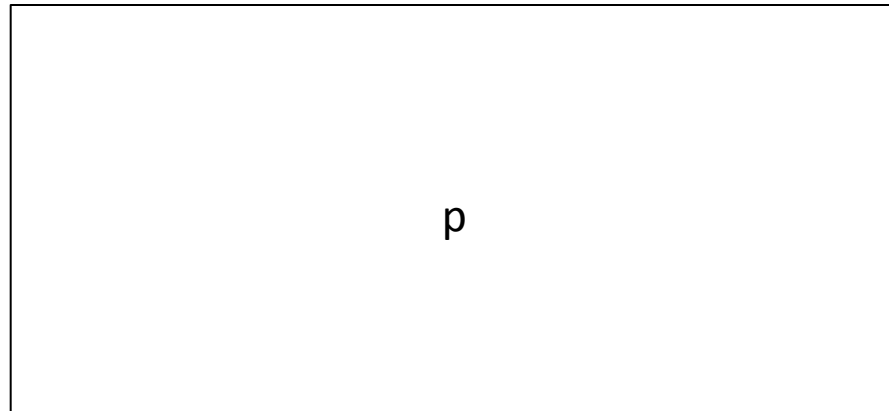


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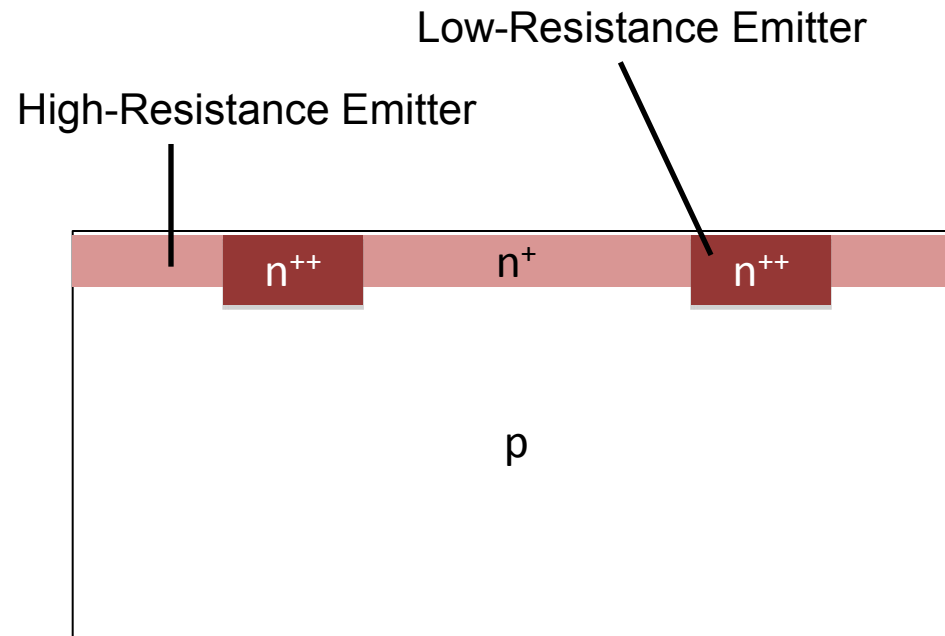
# Cell Fabrication Process: State-of-the-Art

- Saw damage/texturization etch



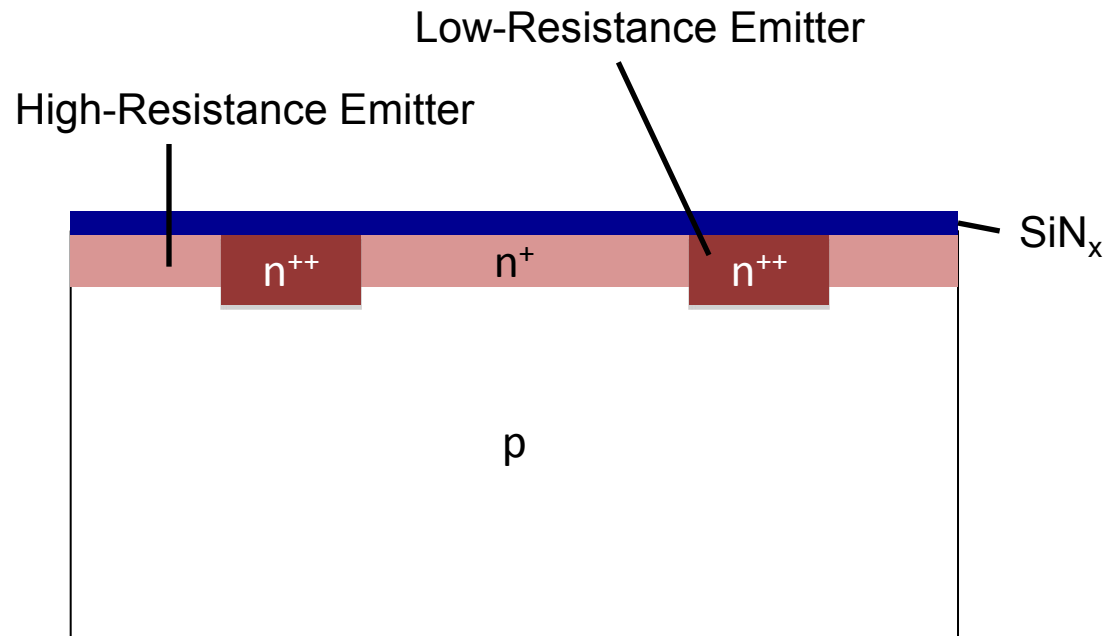
# Cell Fabrication Process: State-of-the-Art

- Saw damage/texturization etch
- Selective emitter diffusion
- PSG etch



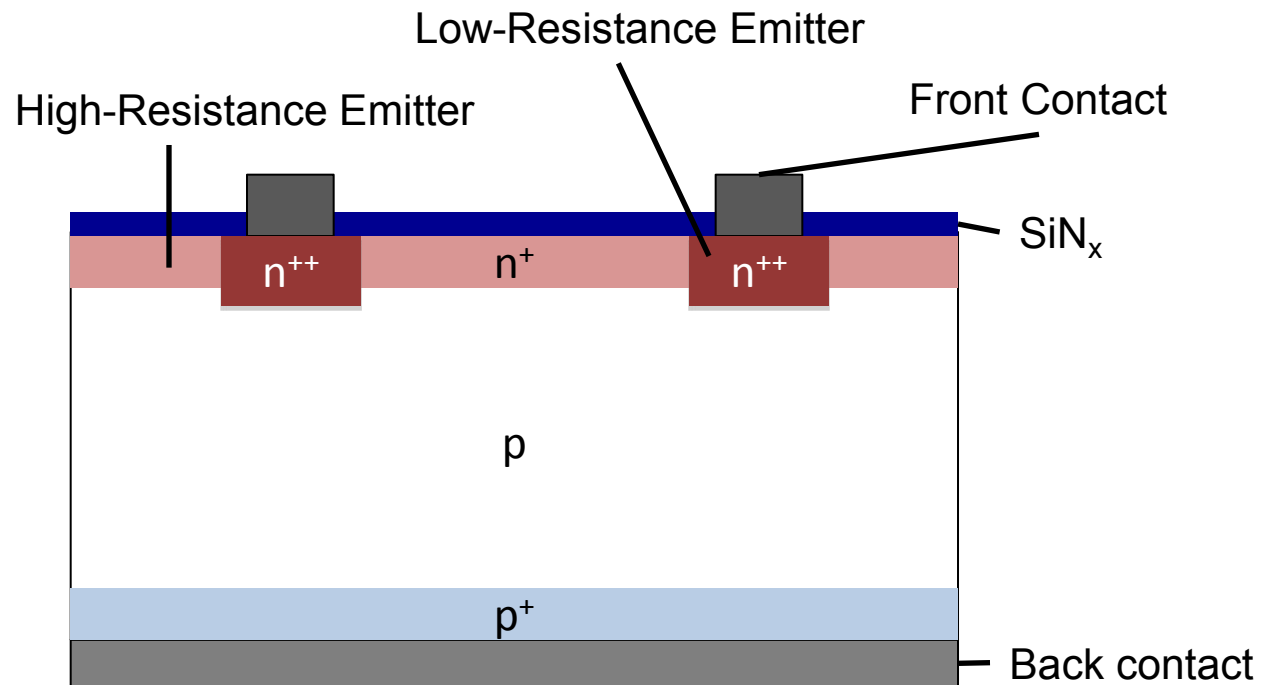
# Cell Fabrication Process: State-of-the-Art

- Saw damage/texturization etch
- Selective emitter diffusion
- PSG etch
- Nitride ARC



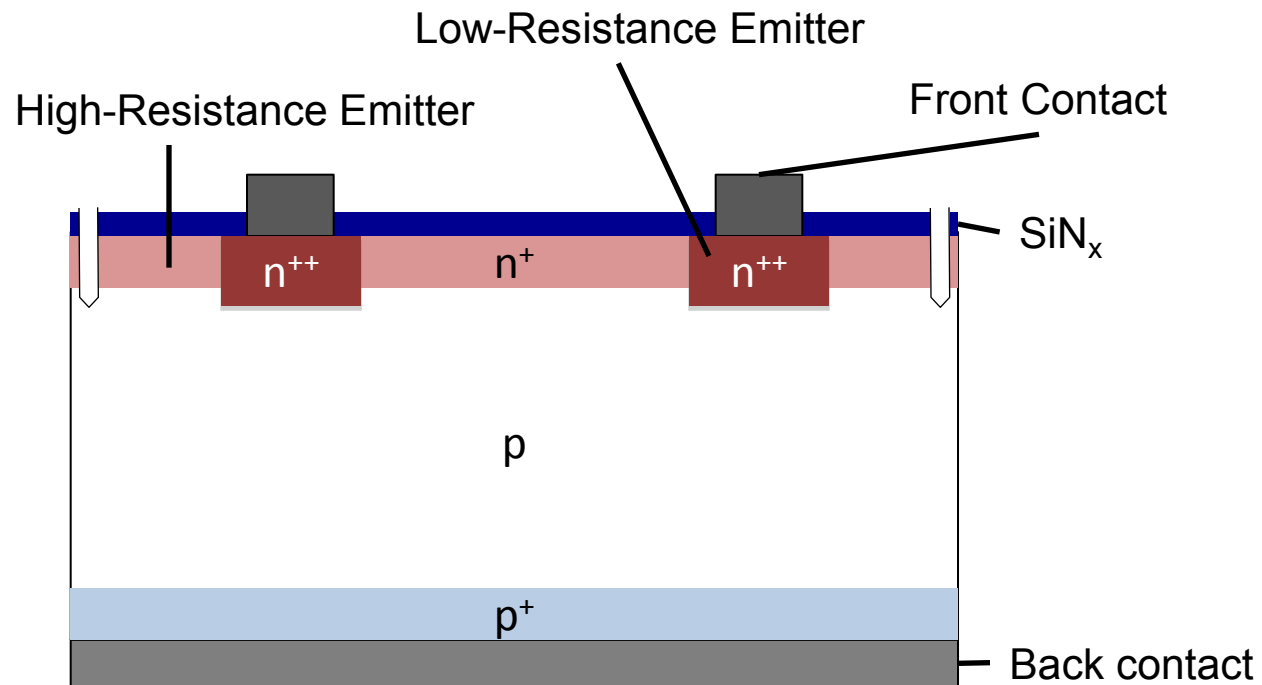
# Cell Fabrication Process: State-of-the-Art

- Saw damage/texturization etch
- Selective emitter diffusion
- PSG etch
- Nitride ARC
- Metallization
- Firing



# Cell Fabrication Process: State-of-the-Art

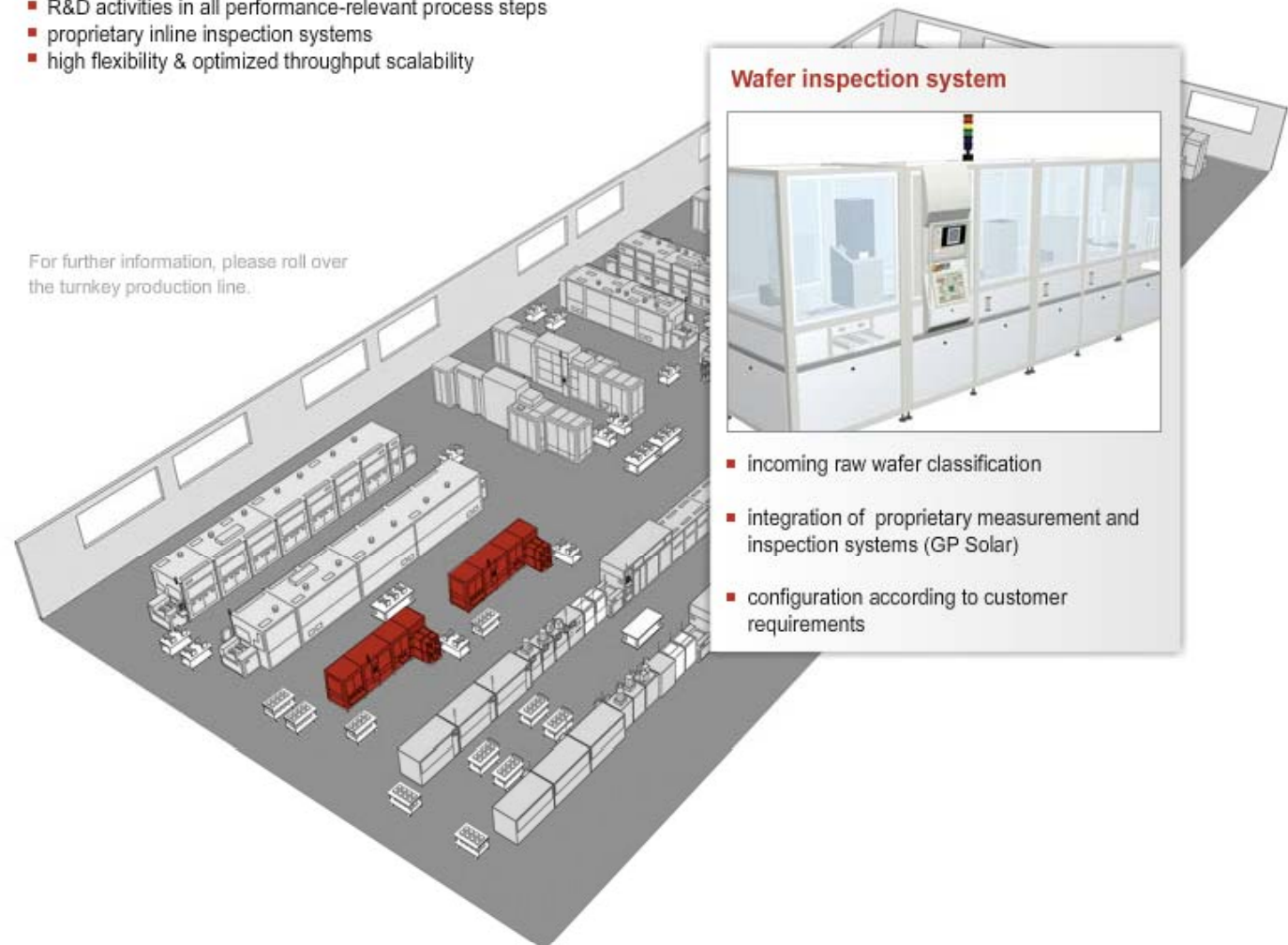
- Saw damage/texturization etch
- Selective emitter diffusion
- PSG etch
- Nitride ARC
- Metallization
- Firing
- Edge isolation
- Test and Sort



# Turn-Key Solar Cell Line

- cell efficiency: >18% (Mono Si), >16.6% (Multi Si)
- future-proof process technology
- R&D activities in all performance-relevant process steps
- proprietary inline inspection systems
- high flexibility & optimized throughput scalability

For further information, please roll over the turnkey production line.



## Wafer inspection system



- incoming raw wafer classification
- integration of proprietary measurement and inspection systems (GP Solar)
- configuration according to customer requirements

[http://www.centrotherm.de/fileadmin/html/flexLine/FlexLine\\_EN.html](http://www.centrotherm.de/fileadmin/html/flexLine/FlexLine_EN.html)

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# In-Line Etch Tools

For the visuals from this slide, please see the lecture video or follow the link below.

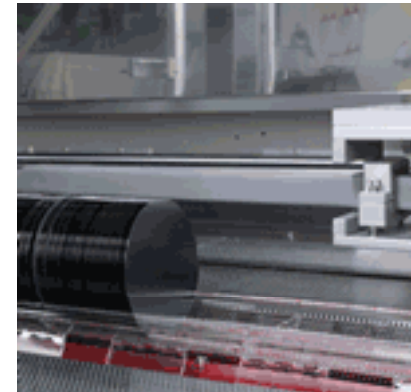
<http://www.rena.com/index.php?id=40&L=1>

# Emitter Diffusion ( $\text{POCl}_3$ ) Tools

Automated, high-volume batch processing for diffusion ( $\text{POCl}_3$ ).



Courtesy of Centrotherm Photovoltaics. Used with permission.



<http://www.centrotherm.de/en/technologies-solutions/photovoltaics/production-equipment/diffusion-furnace/>

# Silicon Nitride ARC

## **Silicon nitride antireflection coatings (ARC)**

Additional benefit: Hydrogen passivation

For the visuals from this slide, please see the lecture video or follow the link below.

<http://www.centrotherm.de/>

[http://www.roth-rau.de/index\\_engl.html](http://www.roth-rau.de/index_engl.html)

# Screen Printing

**Screen printing** for metallization developed, proven.

- > Amazingly, it works, although front metal only contacts a tiny percentage of the emitter!
- > Avoids galvanization, increases throughput.

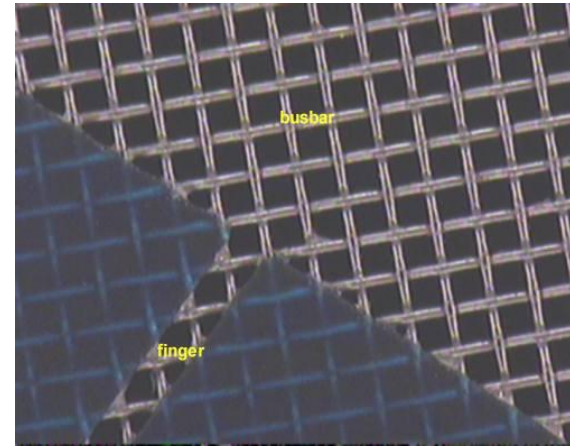
For the additional visuals from this slide, please see the lecture video or follow the links below.

Screen printing a shirt.

<http://www.sportop.com/screen-printing-services.cfm>

Screen printing a solar cell.

<http://www.sportop.com/screen-printing-services.cfm>



Courtesy of [PVCDROM](#). Used with permission.

Solar cell screen

[http://pvcdrom.pveducation.org/MANUFACT/Images/SN\\_MESH.JPG](http://pvcdrom.pveducation.org/MANUFACT/Images/SN_MESH.JPG)

Close-up of screen printed metallization finger

<http://www.polykomp.com/images/ESM300Unplated.gif>

# Test and Sort

For the visuals from this slide, please see the lecture video or follow the links below.

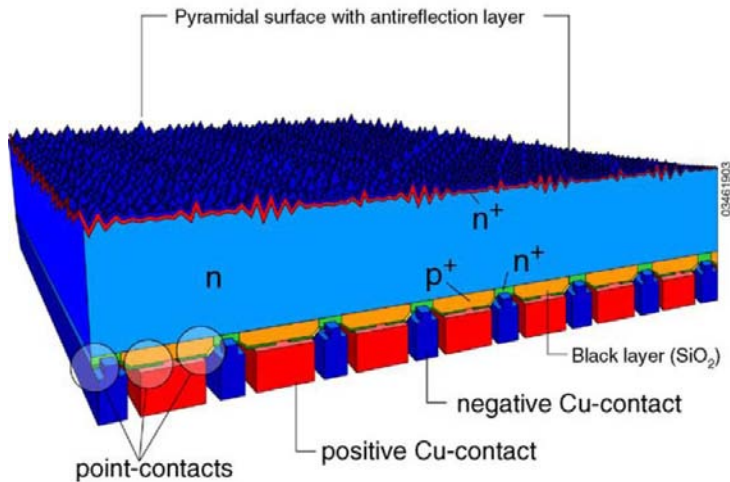
[http://www.spirecorp.com/images/spire\\_solar/products/interconnect\\_solar\\_cells/SPI-ASSEMBLER\\_5000\\_animated.gif](http://www.spirecorp.com/images/spire_solar/products/interconnect_solar_cells/SPI-ASSEMBLER_5000_animated.gif)

<http://www.spirecorp.com/spire-solar/>

<http://www.spirecorp.com/spire-solar/downloads/datasheets-april12009/Spi-Cell%20Sorter%20Rev%20B%2011-08.pdf>

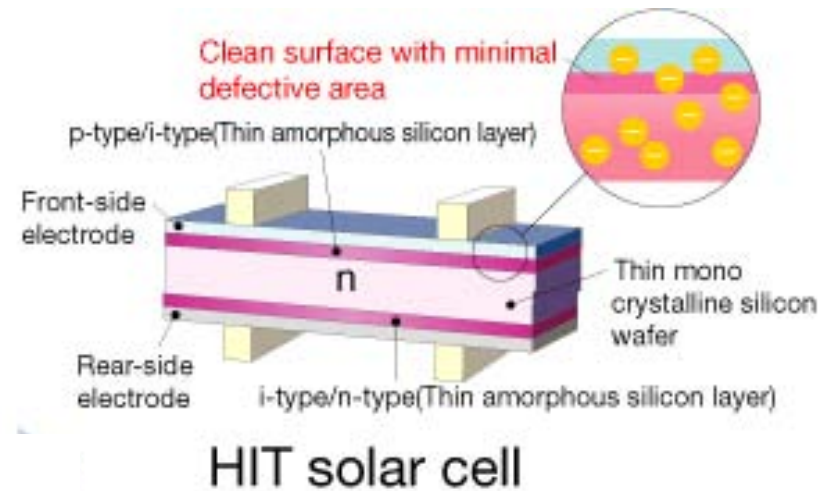
# Very High Efficiency c-Si Architectures

- Examples:
  - SunPower Interdigitated Back Contact (~23.5%)
  - Sanyo HIT Cell (~23%)
- Characteristic Features: Both use n-type silicon



Courtesy of Elsevier, Inc., <http://www.sciencedirect.com>.  
Used with permission.

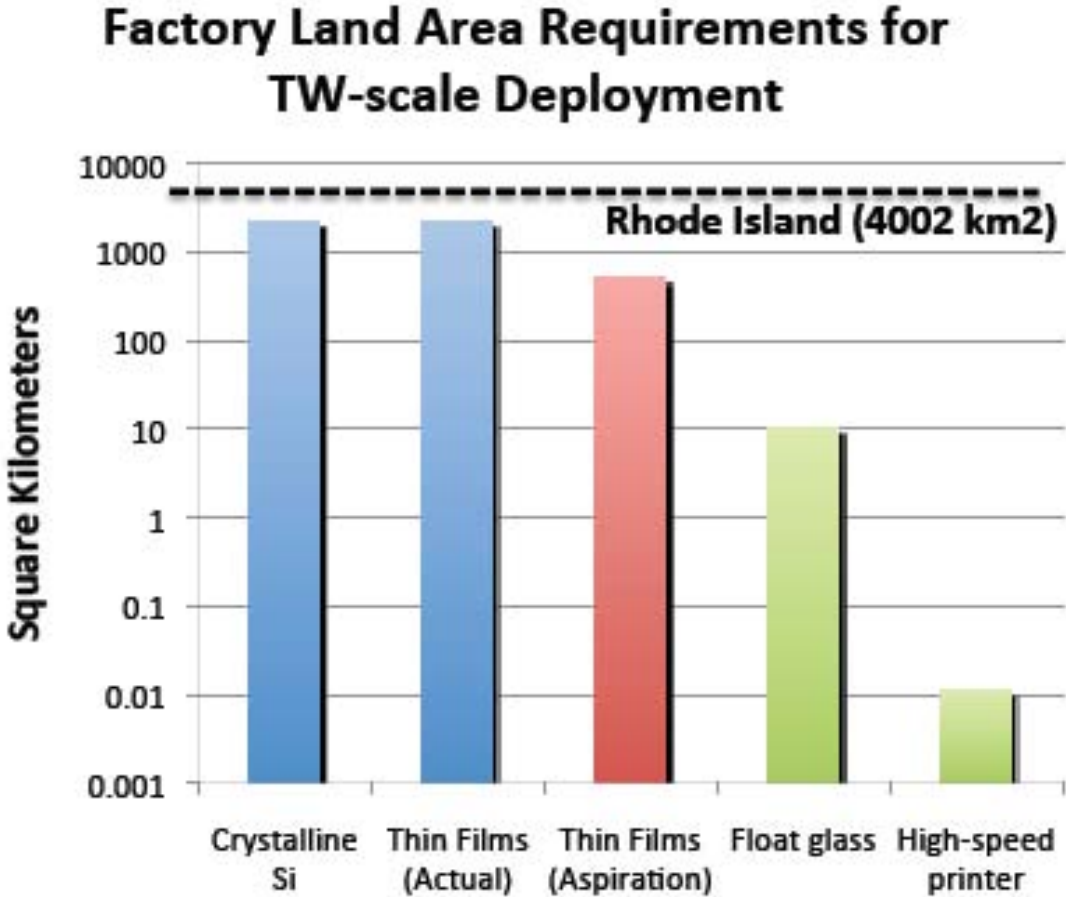
<http://www.sunpowercorp.com>



Courtesy of Panasonic Corporation. Used with permission.

[http://www.sanyo.co.jp/clean/solar/hit\\_e/hit.html](http://www.sanyo.co.jp/clean/solar/hit_e/hit.html)

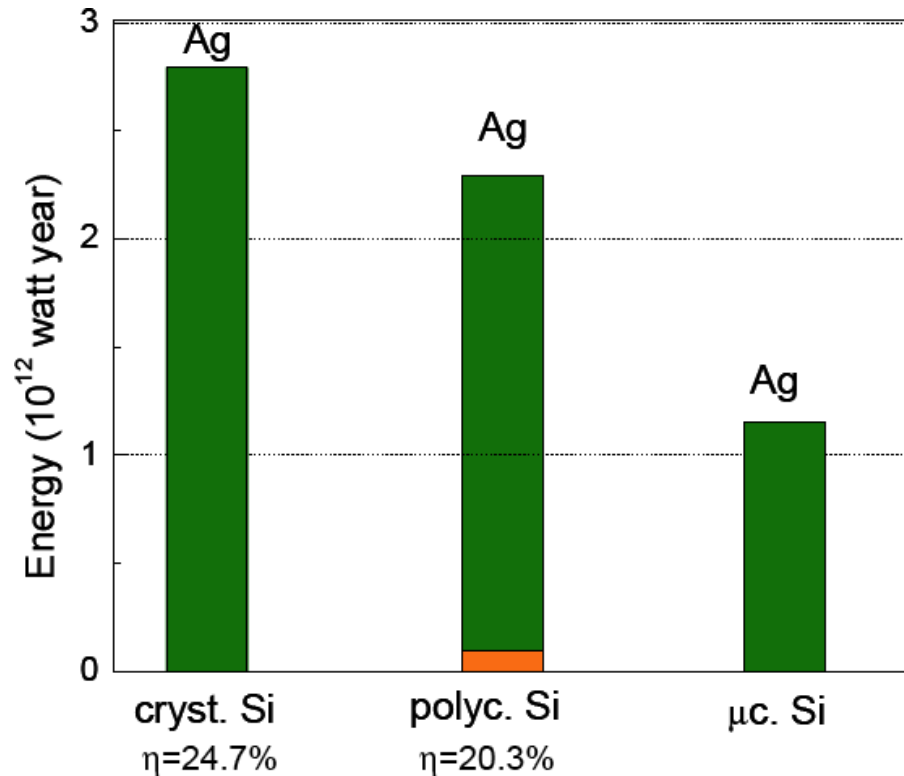
# Manufacturing Barrier to Scale



# Materials Availability

Plenty of (oxidized) silicon in the Earth's crust, but...

Not enough silver! New solar cell contact materials needed.



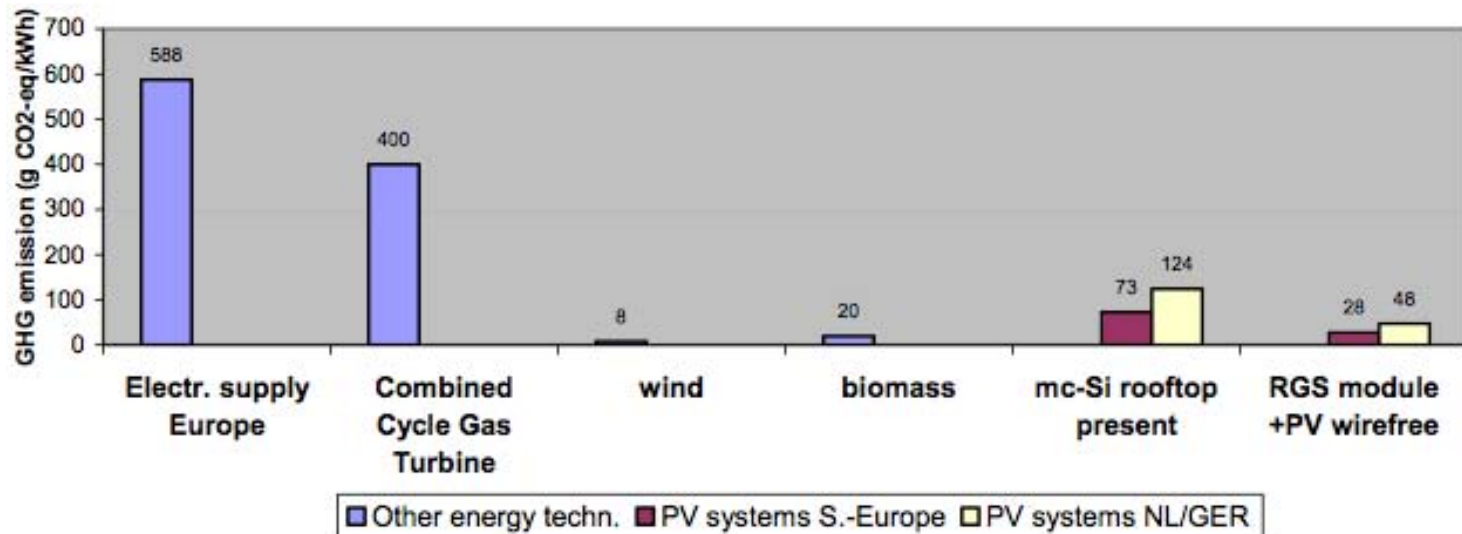
Source: Feltrin, A., and A. Freundlich. "Material Considerations for Terawatt. Level Deployment of Photovoltaics." *Renewable Energy* 33 (2008): 180-5. Courtesy of Alex Freundlich. Used with permission.

Alex Freundlich: [http://www.rio6.com/proceedings/RIO6\\_181106\\_MA\\_1730\\_Freundlich.pdf](http://www.rio6.com/proceedings/RIO6_181106_MA_1730_Freundlich.pdf)



# Environmental Impacts

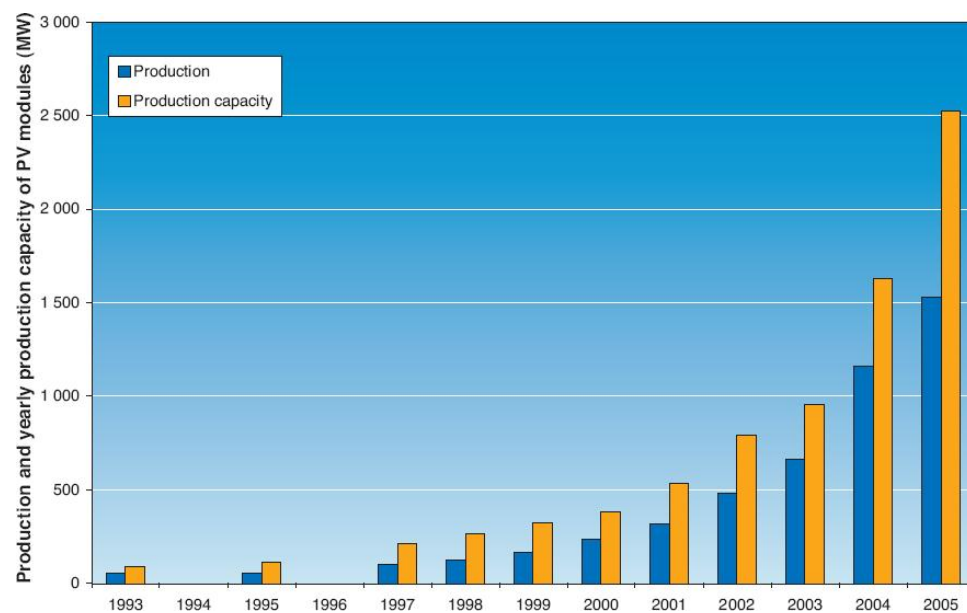
- Links to sources concerning health, safety, and environmental impacts of PV:
  - <http://www.pv.bnl.gov/>
  - <http://lea.web.psi.ch/>
  - <http://www.ecn.nl/>
  - <http://ipts.jrc.ec.europa.eu/activities/energy-and-transport/setplan.cfm>



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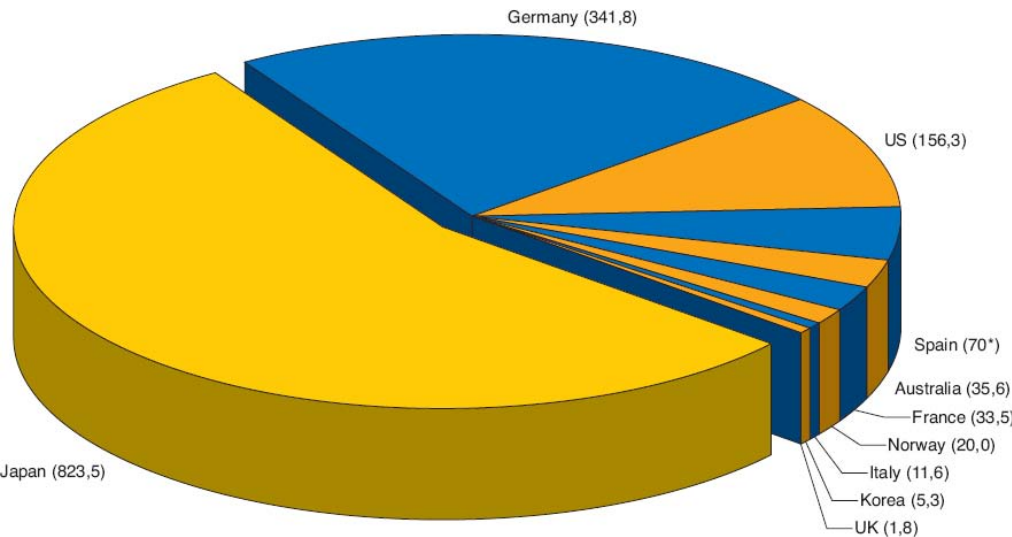
<http://www.ecn.nl/docs/library/report/2004/rx04060.pdf>

# Declining US Market Share



- Sustained 25-40% industry growth rates.
- PV now a \$10+ bi industry.

IEA-PVPS, Report IEA-PVPS T1-15:2006



## US Market Share:

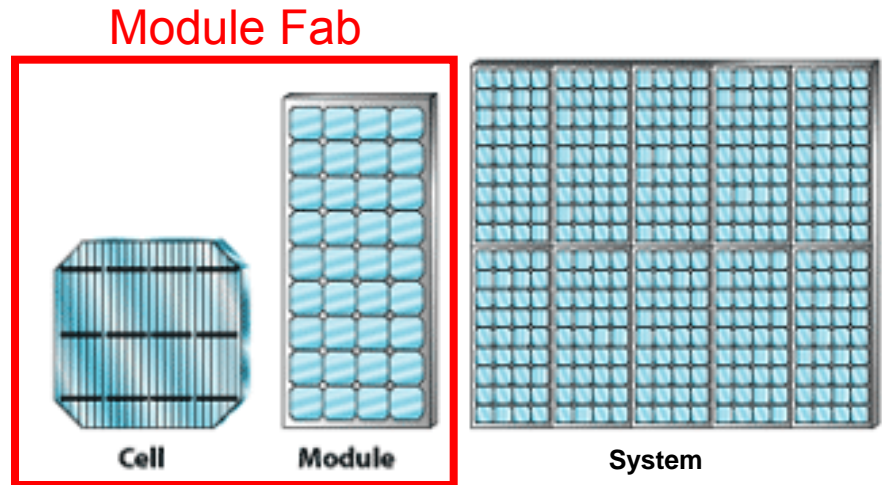
1980: 75%  
 1990: 33%  
 2000: 26%  
 2005: 10%

PV News, PV Insider's Report, Feb. 2001  
 IEA-PVPS: Report IEA-PVPS T1-15:2006

# Silicon-Based Solar Cells Tutorial

- Why Silicon?
- Current Manufacturing Methods
  - Overview: Market Shares
  - Feedstock Refining
  - Wafer Fabrication
  - Cell Manufacturing
  - Module Manufacturing
- Next-Gen Silicon Technologies

# Si-based PV Production: From Sand to Systems



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Public domain image.

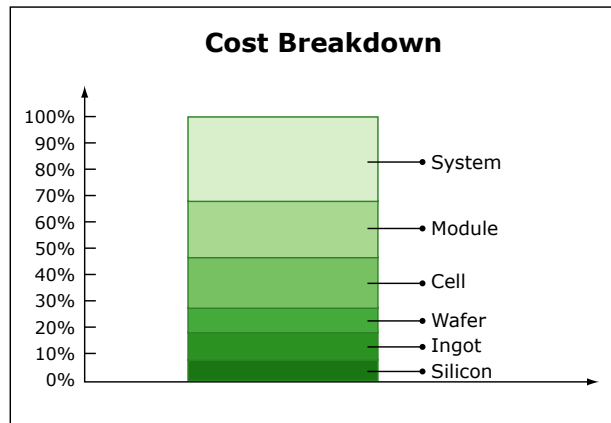


Image by MIT OpenCourseWare. After H. Aulich, PV Crystalox Solar.

# Module Production Line

For related visuals, please see the lecture 11 video.

# Tabbing, Stringing, and Layup

For related visuals, please see the lecture 11 video.

# Module Fabrication

Laminator

Trim and frame

For related visuals, please see the lecture 11 video.

Finish (J-box)

# Barriers to Scale

Fast processing of thin ( $\sim 100\ \mu\text{m}$ ) wafers with high yield!

For related visuals, please see the lecture 11 video.

Suction cups.

[http://www.spirecorp.com/images/spire\\_solar/products/vac\\_660\\_pict\\_4.jpg](http://www.spirecorp.com/images/spire_solar/products/vac_660_pict_4.jpg)

Bernoulli grippers.

[http://www.astec-halbleitertechnologie.de/docs/cc/download/PB\\_WTS-SC.pdf?PHPSESSID=83f7709a94d900a00e3dd1da5e056311](http://www.astec-halbleitertechnologie.de/docs/cc/download/PB_WTS-SC.pdf?PHPSESSID=83f7709a94d900a00e3dd1da5e056311)



# Directional Solidification of mc-Si

*a.k.a. Directional Solidification System (DSS), Casting, Bridgman Process.*

Ingots are initially cut into rectangular blocks called “bricks,” then wire-sawed into wafers.

Please see lecture video for related furnace and brick-cutting images.

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Fall 2011

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